IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): ENDOU et al.

Serial No.: 10/824,497

Filed: April 15, 2004

Title: METHOD OF MANUFACTURING

SILICON CARBIDE

SEMICONDUCTOR DEVICE

Atty. Dkt.: 01-617

Group Art Unit: 2812

Examiner: Unknown

Commissioner for Patents Alexandria, VA 22314

Date: May 5, 2005

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the references listed on the attached Form PTO-1449 are being brought to the attention of the Examiner without any admission that they constitute statutory prior art, or without any admission that they contain subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

Although no fees are believed to be due at this time, it is respectfully requested that any such fees be charged to Deposit Account 50-1147. Also, the Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed references have been considered and made of record.

Respectfully submitted.

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* PATENT APPLICATION

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FORM PTO-1449	ATTY. DKT NO.	01-617	SER. NO.	10/824,497
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MAY 0 5 2005	FILING DATE	April 15, 2004	GROUP	2812
REFERENCE DESIGNATION				

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
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FOREIGN PATENT DOCUMENTS

TRANSLATION

	DOCUMENTAL AND DOCUMENT					SUB CLASS		NO	
<u> </u>	DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS		YES		Eng. Abstract
	WO 01/84609	11/8/01	PCT						

* Full English text is available in machine-translated form in JPO (Japanese Patent Office) English language web site at http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER	DATE CONSIDERED	-

Rev. 10/94 (Form 3.05)